

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
BEFORE THE PATENT TRIAL AND APPEAL BOARD

In re patent of: Chistyakov § Petition for *Inter Partes* Review
§
U.S. Patent No. 6,896,773 § Attorney Docket No.: 34789.98
§
Issued: May 24, 2005 § Customer No.: 27683
§
Title: High Deposition Rate Sputtering § Real Party in Interest: Fujitsu
§ Semiconductor Limited and Fujitsu
§ Semiconductor America, Inc.

PETITIONER POWER OF ATTORNEY PURSUANT TO 37 CFR 42.10(b)
FOR PETITION FOR *INTER PARTES* REVIEW

Petitioners **Fujitsu Semiconductor Limited and Fujitsu Semiconductor America, Inc.** hereby appoint the Practitioner(s) associated with **Customer Number 27683**, as its attorney(s) to prosecute and to transact all business in the Patent Trial & Appeal Board of the United States Patent and Trademark Office connected with *Inter Partes* Review of the above-identified patent.

Please direct all communication regarding this Petition to **Customer Number 27683**:

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The undersigned is authorized to sign this Power of Attorney on behalf of the Petitioners.

Fujitsu Semiconductor Limited

By: Takashi Kikuma

Printed Name: Takashi Kikuma

Title: Director, IP Licensing Department

Fujitsu Semiconductor America, Inc.

By: Jesús E. Martínez

Printed Name: Jesús E. Martínez

Title: General Counsel